



**RESPONSE TO RESTRICTION
REQUIREMENT**

Docket No. F0017/7000

Applicant: Jiankang Huang and Robert C. O'Handley
Serial No: 10/730,355
Filed: December 8, 2003
For: HIGH SENSITIVITY, PASSIVE MAGNETIC FIELD SENSOR AND
METHOD OF MANUFACTURE
Examiner: C.A. Renner
Art Unit: 2652

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

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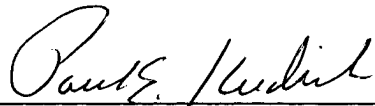

Jan L. Mellen

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This is responsive to the restriction requirement dated March 15, 2006. In response to the examiner's restriction, Applicants hereby elect the claims identified as Group I, including claims 1-31. Accordingly, claims 32-42 have been cancelled as drawn to non-elected subject matter.

Any questions regarding this matter may be directed to the undersigned. The Commissioner is hereby authorized to charge any fees due for the filing of this paper to the Applicants' Attorneys' Deposit Account 02-3038.

Respectfully submitted



Date: 4/12/06

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